

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Akira SATO

Application No.: U.S. National Stage of PCT/JP99/01520

Filed: November 23, 1999

Docket No.: 104788

For: METHOD OF MANUFACTURING SEMICONDUCTOR DEVICE, MOLDING  
DEVICE FOR SEMICONDUCTOR DEVICE, AND SEMICONDUCTOR DEVICE

PRELIMINARY AMENDMENT

Assistant Commissioner of Patents  
Washington, D. C. 20231

Sir:

Prior to initial examination, please amend the above-identified application as follows:

IN THE CLAIMS:

Please amend claims 5, 6, 8, 14, 17-20, 25, 29 and 30 as follows:

Claim 5, line 2, change "any one of claims 1 to 4" to --claim 1--.

Claim 6, line 2, change "any one of claims 2 to 4" to --claim 2--.

Claim 8, line 2, change "any one of claims 2 to 4" to --claim 2--.

Claim 14, line 2, delete "or 13".

Claim 17, line 2, delete "or 16".

Claim 18, line 2, delete "or 16".

Claim 19, line 2, delete "or 16".

Claim 20, line 2, delete "or 16".